

Supplementary information

Thin films composed of Zr-doped In_2O_3 grains rich in fracture surfaces and cracks for photoelectrochemical water oxidation

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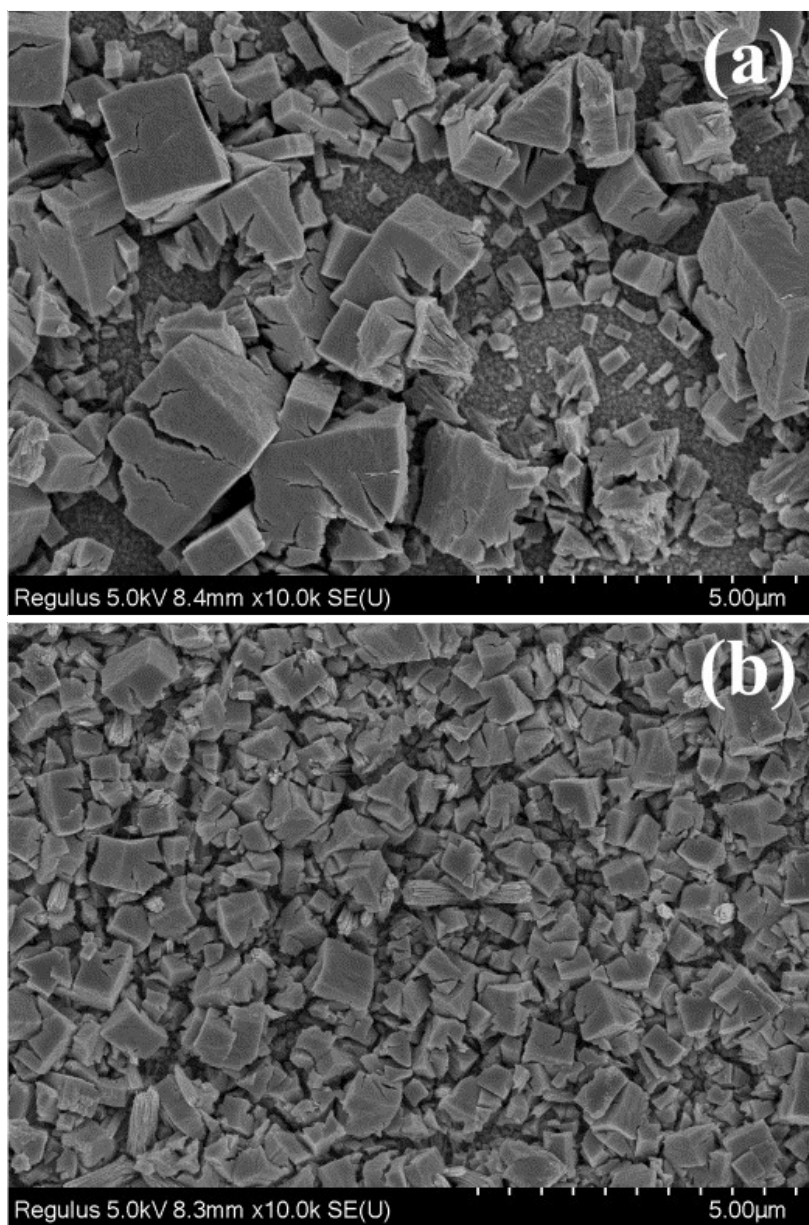


Fig. S1 SEM images of undoped In_2O_3 (a) and 14.5%-Zr- In_2O_3 (b) samples.

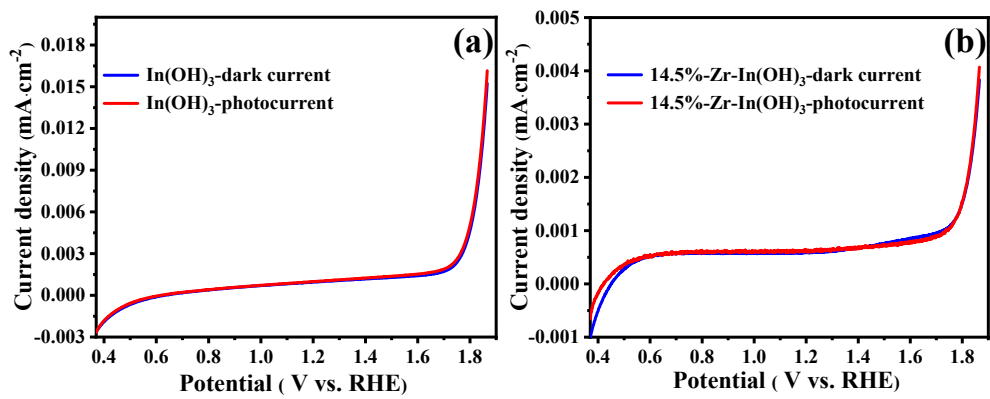


Fig. S2 LSV curves of the undoped and 14.5%-Zr-In(OH)₃ films measured under AM1.5G illumination at 100 mW·cm⁻² and in dark.

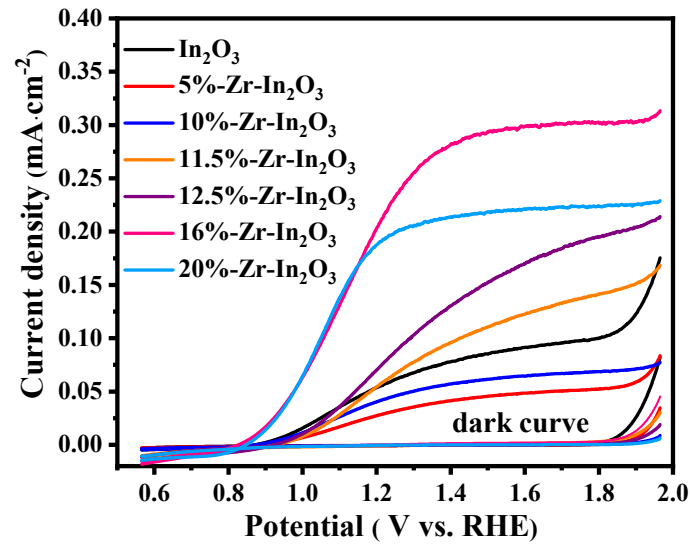


Fig. S3 LSV curves of undoped and Zr-doped In_2O_3 films measured under AM1.5G illumination at $100\text{ mW}\cdot\text{cm}^{-2}$ and in dark.

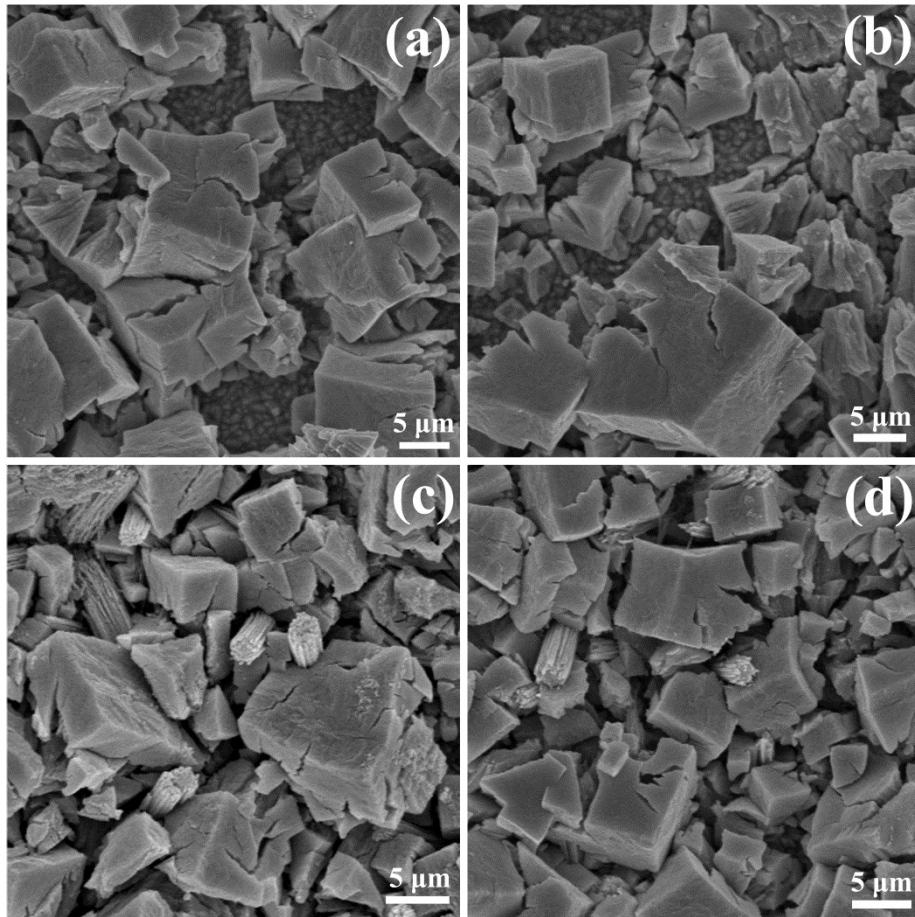


Fig. S4 SEM images of In₂O₃ before (a) and after (b) PEC test; SEM images of 14.5%-Zr-In₂O₃ before (c) and after (d) PEC test.

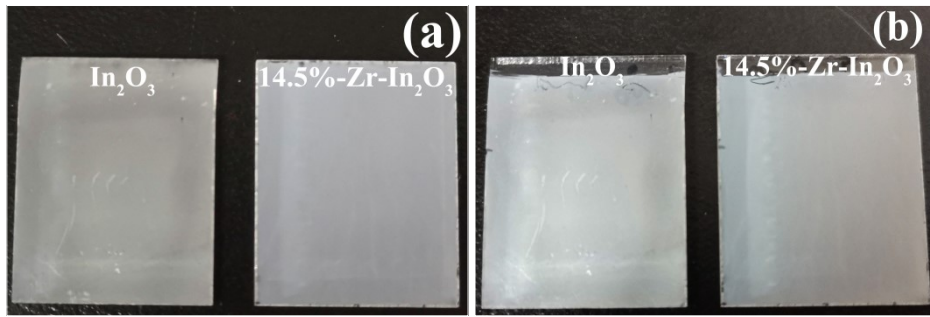


Fig. S5 The optical photos of In_2O_3 and $14.5\%-\text{Zr}-\text{In}_2\text{O}_3$ samples before (a) and after (b) PEC tests.

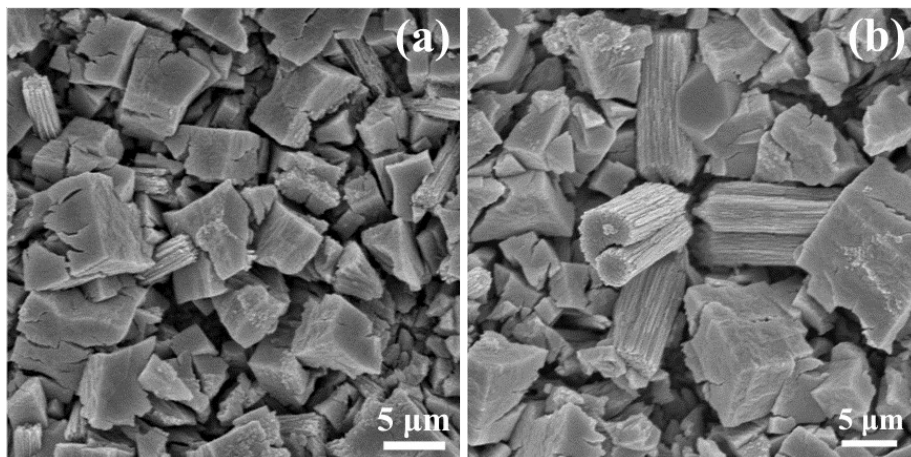


Fig. S6 SEM images of 14.5%-Zr-In₂O₃ prepared from 14.5%-Zr-In(OH)₃ with a heating rate of (a) 0.5°C·min⁻¹ and (b) 3°C·min⁻¹.

Table S1 The contents of In, O and Zr in the Zr-doped In₂O₃ samples measured by EDS.

Sample	Element	Normalized quality C [wt.%]	Atomic number C [atm.%]
12.5%-Zr-In₂O₃	In	72.85	29.99
	O	22.96	67.84
	Zr	4.18	2.17
14.5%-Zr-In₂O₃	In	74.37	31.90
	O	21.38	65.81
	Zr	4.25	2.30
16%-Zr-In₂O₃	In	69.17	26.82
	O	25.34	70.51
	Zr	5.49	2.68
20%-Zr-In₂O₃	In	67.63	25.67
	O	26.21	71.39
	Zr	6.16	2.94

Table S2 PEC water splitting performance of some In₂O₃-based photoanodes.

Photoanodes	Synthesis Method	Substrate	Light Source	Electrolyte	Photocurrent Density	Ref.
cubic In ₂ O ₃	chemical bath reaction method	FTO	35 mW·cm ⁻²	0.1M Na ₂ SO ₄ (pH=7)	1.15 mA·cm ⁻² at 1.51 V vs RHE	1
In ₂ O ₃ nanorods	electrodeposition	FTO	-	1M CH ₃ OH, NaOH (pH=12)	2.0 μA·cm ⁻² at 0 V vs Ag/AgCl	2
In ₂ O ₃ nanostructures	solvothermal method	FTO	100 mW·cm ⁻²	0.1M NaOH	0.4 mA·cm ⁻² at 1.30 V vs RHE	3
In ₂ O ₃ /In ₂ S ₃ heterostructures	two-step hydrothermal method	FTO	-	1 M NaOH	0.53 mA·cm ⁻² at 1.23 V vs RHE	4
Mn-doped In ₂ O ₃ film	RF-magnetron sputtering technique	Si	160 mW·cm ⁻²	1 M NaOH	120 μA·cm ⁻² at 0.4 V vs Ag/AgCl	5
Indium Oxide Microcubes	chemical-bath-deposited	ITO	100 mW·cm ⁻²	1M KOH	0.44 mA·cm ⁻² at 0.5 V vs Ag/AgCl	6
Sub-50 nm nanoporous In ₂ O ₃ spheres	solvothermal	FTO	-	0.1M Na ₂ SO ₄	1.9 mA·cm ⁻² at 0.65 V vs Ag/AgCl	7
In ₂ O ₃ Nanowires	chemical vapor deposition (CVD)	Si	270 mW·cm ⁻²	1 M NaOH	0.21 mA·cm ⁻² at 0.22 V vs Ag/AgCl	8
Nitrogen doped In ₂ O ₃ thin film	solvothermal	FTO	130 mW·cm ⁻²	1.0 M KOH	140 μA·cm ⁻² at 0.4 V vs Ag/AgCl	9
Zr-doped In ₂ O ₃ film	hydrothermal method	FTO	100 mW·cm ⁻²	0.1 M NaOH	0.30 mA·cm ⁻² at 1.50 V vs RHE	This work

Table S3 The Nyquist plots fitting results of the undoped In_2O_3 and 14.5%-Zr- In_2O_3 .

Sample	R_s ($\Omega\cdot\text{cm}^2$)	R_{ct} ($\Omega\cdot\text{cm}^2$)
undoped In_2O_3	31.21	4364
14.5%-Zr-In_2O_3	28.27	2885

Table S4 Flat-band potentials and donor densities originated from the linear portion of the Mott–Schottky plots that shown in Fig. 9b in the main text.

Sample	Flat-band potential (V vs. RHE)	Donor density (cm⁻³)
undoped In₂O₃	0.55	3.60×10 ²¹
14.5%-Zr-In₂O₃	0.49	10.88×10 ²¹

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